

Notice of References Cited	Application/Control No. 10/763,395	Applicant(s)/Patent Under Reexamination KWON ET AL.	
	Examiner Christine M. Behncke	Art Unit 3661	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,657,104	04-1987	Holland, John M.	180/211
*	B	US-5,610,488	03-1997	Miyazawa, Osamu	318/568.11
*	C	US-6,553,271	04-2003	Morrell, John B.	700/75
*	D	US-7,082,350	07-2006	Skoog, Hans	700/245
*	E	US-2003/0009259	01-2003	Hattori et al.	700/245
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP2001-138272	11-1999	Japan	Jinichi 2001-05-22	B25J 5/00
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

JP
04/07/09